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Docket No.: 2328-050A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : EXPEDITED PROCEDURE
Jian J. CHEN et al. : Response under 37 CFR 1.116
U.S. Patent Application No. 10/647,347 : Confirmation No. 3505
Filed: August 26, 2003 : Group Art Unit: 1763
For: INDUCTIVE PLASMA PROCESSOR METHOD : Examiner: LUZ L ALEJANDRO

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

May 9, 2005

Sir:

This paper is submitted in reply to the Office Action mailed March 9, 2005, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.